

DOCKET NO: CU-3305

Please Enter *(SDF 1/12/04)* PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

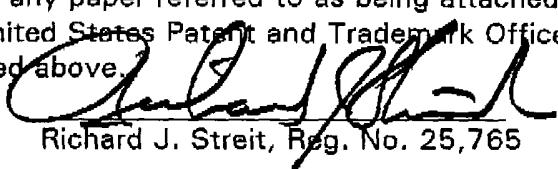
In re Application: Joon Hyeon LEE] GRP ART UNIT: 2812
 Serial No: 10/622,351]
 Filed: July 18, 2003] Ex.: Isaac, Stanetta D.
 For: METHOD FOR FORMING ISOLATION FILM FOR SEMICONDUCTOR
 DEVICES

Certification under 37 C.F.R. §1.8(a)

The USPTO Fax No. (703) 746-8483 (TC2800: Examiner's Direct Fax)

Date of Fax Transmittal: January 15, 2004

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.



Richard J. Streit, Reg. No. 25,765

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

APPOINTMENT OF ASSOCIATE ATTORNEY

Dear Sir:

The undersigned Attorney for Applicant in the above identified application for Letters Patent, hereby appoints **Woochoon William Park, Reg. P-55,523** as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

Please address and send all correspondence to:

Richard J. Streit
 Ladas & Parry
 224 South Michigan Avenue
 Chicago, Illinois 60604
 Customer No. 26530

Dated: January 15, 2004


Richard J. Streit, Reg. 25,765
 c/o Ladas & Parry
 224 South Michigan Avenue
 Chicago, Illinois 60604
 (312) 427-1300